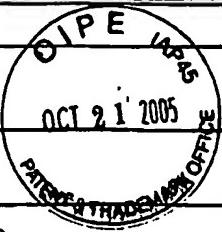


INFORMATION DISCLOSURE STATEMENT



| FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) | | | ATTY DOCKET NO. 2003_0966A | SERIAL NO. 10/619,006 | | | |
|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----|-----------------|---------------------------------|-----------------------------|-------|----------|----------------------------|
| Date Submitted to PTO: October 21, 2005 | | | APPLICANT Keishi KUBO et al. | | | | |
| | | | FILING DATE July 15, 2003 | GROUP 2877 | | | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| *EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES NO |
| RN | AJ | 11-201747 | 7/1999 | JP | | | Abstract |
| PA | AK | 11-195054 | 7/1999 | JP | | | Abstract |
| | AL | | | | | | |
| | AM | | | | | | |
| | AN | | | | | | |
| OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
| | AO | | | | | | |
| | AP | | | | | | |
| | AQ | | | | | | |
| EXAMINER | | | | DATE CONSIDERED 31 Oct 2005 | | | |

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

Date Submitted to PTO: November 10, 2003

ATTY DOCKET NO.
2003-0966ASERIAL NO.
10/619,006APPLICANT
Keishi KUBO et al.FILING DATE
July 15, 2003GROUP
2877

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| RNP | AA | 6,480,286 | 11/2002 | Kubo et al. | | | |
| | AB | | | | | | |
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| | AH | | | | | | |
| | AI | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES NO |
|--|----|-----------------|------|---------|-------|----------|--------------------|
| | AJ | | | | | | |
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| | AM | | | | | | |
| | AN | | | | | | |

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

| | | |
|----------|----|--------------------------------------------------------------------------------------------------------------------------------------------------|
| <i>m</i> | AO | SEMI M1-0701 ^E "Specification for Polished Monocrystalline Silicon Wafers", SEMI M1-0701 ^E © SEMI 1978, 2001, pages 1- 26. |
| <i>m</i> | AP | SEMI M1.15-1000 "Standard for 300mm Polished Monocrystalline Silicon Wafers (Notched)", pages 1-3, SEMI M1.15-1000 © SEMI 1978, 2001. |
| | AQ | |

EXAMINER *Richard J.*DATE CONSIDERED *25 Oct 2003*